

LIST OF ART CITED BY APPLICANT

(Use several sheets if necessary)

Atty Docket No. A01215A	Serial No.
Applicant Anne Mae Gaffney, et al.	
Filing Date Herewith	Group

U.S. Patent Documents

EXAMINER INITIALS		DOCUMENT NUMBER	DATE	NAME	Class/Subclass	FILING DATE IF APPROPRIATE
<i>ks</i>	AA	5,281,745	1/25/1994	Ushikubo, et al.	—	
	AB	5,380,933	1/10/1995	Ushikubo, et al.	—	
	AC	6,043,185	3/28/2000	Cirjak, et al.	—	
	AD	5,472,925	12/05/1995	Ushikubo, et al.	—	
<i>ks</i>	AE	6,080,882	6/27/2000	Midorikawa, et al.	—	
	AF					
	AG					
	AH					
	AI					
	AJ					

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	Class/Subclass	Translation Yes/No
<i>ks</i>	AK	0 630 879 B1	12/28/1994	Europe	—	
	AL	WO 00/09260	2/24/2000	WIPO		
	AM	WO 00/29106	5/25/2000	WIPO		
	AN	7-53448	2/28/1995	Japan		Yes
	AO	2000-37623	2/8/2000	Japan		Yes
<i>ks</i>	AP	0 281 280	9/07/88	Europe	—	

OTHER ART (Including Author, Title, Date, Pertinent Patents, etc.)

<i>ks</i>	AR	Translation of Japanese Laid-Open Patent Application Publication No. 6-228073(8/16/94).
<i>ks</i>	AS	of Japanese Laid-Open Patent Application Publication No. 2000-254496(9/19/2000).
	AT	

Examiner *keamal saeed*Date Considered *03/01/05*

*EXAMINER: Initial reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not conformance and not considered. Include copy of this form with next communication to applicant.